



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**PATENT**

#9 / Assoc  
P/atty

**In re Application of:**

**Gurtej S. Sandhu**

**Serial No.: 09/023,146**

**Filed: February 12, 1998**

**For: TUNGSTEN SILICIDE (WSIx)  
DEPOSITION PROCESS FOR  
SEMICONDUCTOR MANUFACTURE**

**Examiner: T. Dang**

**Group Art Unit: 2823**

**Attorney Docket No.: 3369US  
(91-365-RE)**

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Sir:

In accordance with 37 C.F.R. § 1.34(b), please recognize the following individual as an associate agent/attorney herein in connection with the above-identified patent application:

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Respectfully submitted,

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